

Dedicated in Honor of Nobel Laureate in Chemistry, Prof. Aaron Ciechanover



Dr. Aaron Ciechanover

# 2025 SIPS

Covering Sustainability Pillars :

- ① Science, Technology & Industry
- ② Governance & Management
- ③ Education & Civil Society

17-20 November 2025, Dusit Thani Mactan Resort, Cebu, Philippines

## 2nd International Symposium on Endourology: Innovations, Technology, and Sustainability in Advancing Urological Practices

The Symposium is being held under the umbrella of SIPS 2025 covering the following topics:

- Sustainability in Urology: Ideas for a Greener Future
- Sterilization of endoscopic instruments
- Current AI Applications in Endourology
- Carbon Footprint in Flexible Ureteroscopy
- Reuse of Single Use Devices in Endourology
- Emerging Endoscopic Robotic Platforms

Scan for Complete Scope & Important Deadlines

Featuring Many Nobel Laureates:



Dan Shechtman  
2011 - Chemistry



Harvey J. Alter  
2020 - Medicine



Gregg L. Semenza  
2019 - Medicine



Joachim Frank  
2017 - Chemistry



Konstantin Novoselov  
2010 - Physics



Aaron Ciechanover  
2004 - Chemistry



Avram Hershko  
2004 - Chemistry



Kurt Wüthrich  
2002 - Chemistry



Rudy A. Marcus  
1992 - Chemistry



Jean-Marie Lehn  
1987 - Chemistry

Special Address:



Malcolm McNeil  
President  
Beverly Hill Bar  
Association  
USA



Donna J. Nelson  
2016 President  
American Chemical  
Society  
USA



Subra Suresh  
President, Global  
Learning Council  
Switzerland  
Former Director  
NSF, USA



Nektarios Tavernarakis  
Chair  
EIT Governing Board  
President  
FORTH



Louise Otis  
International Judge,  
Mediator and Arbitrator  
(Photo by BAnO)



Haruhiko Inufusa  
CEO  
TIMA  
Japan

**FLOGEN**  
STAR OUTREACH

CHAIRS:



Marcelo Esteves Campos  
UFMG  
Brazil

Summit Website: [www.flogen.org/sips2025](http://www.flogen.org/sips2025) Contact: Dr Florian Kongoli ([fkongoli@flogen.org](mailto:fkongoli@flogen.org))  
Phone: 1 514 807-8542 Toll Free: 1 877 2-FLOGEN (Within North America) Fax: 1 514 344-0361